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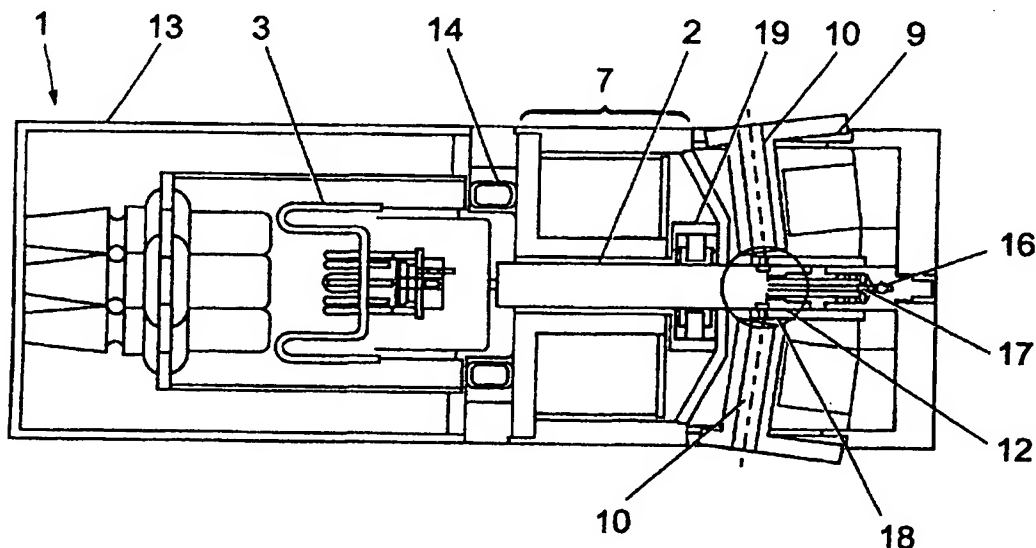
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(54) Title: X-RAY GENERATOR



(57) Abstract

An X-ray generator comprises an evacuated and sealed X-ray tube, an electron gun, an X-ray target, an internal electron mask, and an X-ray window consisting of a thin tube of material with low X-ray absorption and high mechanical strength, for example beryllium. The window connects the tube to the target assembly containing the X-ray target. The generator preferably also includes a system for focusing and steering the electron beam onto the target, a cooling system to cool the target material, kinematic mounts to allow precise and repeatable mounting of X-ray devices for focusing the X-ray beam, and X-ray focusing devices of varying configurations and methods. The X-ray generator of the invention produces an X-ray source having a focal spot or line of very small dimensions and is capable of producing a high intensity X-ray beam at a relatively small point of application using a low operating power.

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1     X-Ray Generator

2

3     This invention relates to an X-ray generator and in  
4     particular to an X-ray generator suitable to be closely  
5     coupled to a focusing X-ray device.

6

7     X-ray generators comprise an electron gun, an X-ray  
8     target and an X-ray exit window, generally in a sealed  
9     vacuum. Prior art generators produce X-ray beams  
10    having a relatively large focal spot or line. Many  
11    applications require a precisely collimated X-ray beam.  
12    To achieve this relatively small apertures are coupled  
13    with the generator to restrict beam diameter and  
14    divergence, but this results in a large loss of X-ray  
15    intensity.

16

17    For many applications the most effective way of using  
18    the X-rays emitted from the target of an X-ray tube is  
19    to form an image of the source, i.e. of the electron  
20    focus on the target, on the specimen. For  
21    crystallographic applications, it is normally essential  
22    that the convergence or divergence of the rays incident  
23    on the sample be very small. To maximise the X-ray  
24    intensity at the sample the angle of collection at the  
25    source should be as large as possible. The combination

1 of these two requirements implies that the imaging  
2 optics should magnify. The sample size determines the  
3 maximum useful image size (see Fig. 3). Fig. 3 shows  
4 that the ratio of the collecting angle  $\alpha$  at the source  
5 S to the beam convergence angle  $\beta$  at the image I is  
6 equal to the magnification of the focusing collimator  
7 or focusing mirror F. In single-crystal  
8 diffractometry, for example, the specimen crystal is  
9 frequently about 300  $\mu\text{m}$  in diameter. The X-ray source  
10 should, therefore, be much smaller than 300  $\mu\text{m}$ .

11  
12 Maximum power loading of the target, without damage to  
13 its surface is greatest when the source is a line focus  
14 at a small take-off angle to give a foreshortening of  
15 about 10 times.

16  
17 It is an object of the present invention to provide an  
18 X-ray generator which produces an X-ray source having a  
19 focal spot or line of very small dimensions. It is a  
20 further object of the present invention to provide an  
21 X-ray generator capable of producing a high intensity  
22 X-ray beam at a relatively small point of application  
23 using a low operating power.

24  
25 According to a first aspect of the invention there is  
26 provided an X-ray generator comprising an electron gun,  
27 electron focusing means and a target, the electron  
28 focusing means being arranged such that the X-ray  
29 source on said target may be varied in size and/or  
30 shape and/or position.

31  
32 Preferably the X-ray source on said target may be  
33 varied from a small diameter spot to a line of small  
34 width.

35  
36 Preferably the generator further comprises an X-ray

1 exit window comprising a tube of material with low X-  
2 ray absorption and of a small diameter to allow close  
3 coupling of X-ray focusing devices.

4  
5 Preferably the electron focusing means comprises an  
6 electron beam focusing means mounted around the X-ray  
7 tube. The electron beam focusing means may comprise an  
8 x-y deflection system for centring the electron beam in  
9 the X-ray tube. The electron beam focusing means may  
10 further comprise at least one electron lens, preferably  
11 an axially symmetric or round lens, and at least one  
12 quadrupole or multipole lens for focusing the electron  
13 beam to a line focus. The line focus preferably has an  
14 aspect ratio in the range 1:1 to 1:20.

15  
16 The electron beam lenses may be magnetic or  
17 electrostatic and are preferably electronically  
18 controlled.

19  
20 Preferably the material of the exit window has a high  
21 mechanical strength and is preferably beryllium. The  
22 exit window may form part of the mechanical structure  
23 of the X-ray tube and preferably connects the X-ray  
24 tube and the target.

25  
26 Preferably the target is metal, most preferably a metal  
27 selected from the group Cu, Ag, Mo, Rh, Al, Ti, Cr, Co,  
28 Fe, W, Au. In a preferred embodiment the target is  
29 copper. The target surface may be orientated such that  
30 the plane of the target surface is perpendicular or at  
31 an angle to the axis of the X-ray tube.

32  
33 The target may comprise a thin metal layer deposited on  
34 a thicker substrate of a material with high thermal  
35 conductivity. Preferably the substrate material is  
36 diamond.

1 Preferably the generator further comprises a target  
2 cooling means. According to a first embodiment the  
3 cooling means may comprise means for directing a jet of  
4 fluid onto the target, on the opposite side of the  
5 target to the side on which the electron beam impinges.  
6 The fluid is preferably air or water. According to a  
7 second embodiment the cooling means may comprise means  
8 for effecting heat transfer by conduction or convection  
9 from the target.

10

11 Preferably the generator further comprises a deflection  
12 means which spatially scans the position of the  
13 electron beam over the face of the target.

14

15 Preferably the generator further comprises an electron  
16 mask having an aperture adapted to align the focal spot  
17 of the electron beam.

18

19 According to a second aspect of the invention there is  
20 provided an X-ray generator comprising an electron gun,  
21 an X-ray tube, a target and an X-ray exit window  
22 comprising a tube of material with low X-ray absorption  
23 and of small diameter to allow close coupling of X-ray  
24 focusing devices.

25

26 According to a third aspect of the invention the  
27 generator according to the first or second aspects is  
28 coupled with an X-ray focusing means. The X-ray  
29 focusing means preferably comprises a mirror.

30

31 The X-ray source according to the invention is designed  
32 specifically to be closely coupled to focusing X-ray  
33 devices. It is able to produce a focal spot or line of  
34 very small dimensions, and thus maximise the benefit of  
35 the focusing methods.

36

1 The distance from the electron focus to the exit window  
2 exterior is very small, and can be as low as 7 mm or  
3 less for a reflection target, or less than 1 mm for a  
4 foil transmission target.

5

6 The X-ray generator according to the invention is  
7 compact and provides a sealed tube.

8

9 The X-ray generator according to the invention needs  
10 only low power because of the efficiency of the  
11 collection and subsequent delivery of X-rays to the  
12 sample.

13

14 The generator achieves a high brilliance, defined as X-  
15 ray power per unit area per steradian.

16

17 An embodiment of the invention will now be described,  
18 by way of example only, with reference to the  
19 accompanying figures, where:

20

21 Fig. 1 shows a longitudinal section through an X-ray  
22 generator according to the invention;

23

24 Fig. 2 shows a detail to an enlarged scale of part of  
25 the X-ray generator shown in Fig. 1;

26

27 Fig. 3 shows the relationship between the size of an X-  
28 ray source and the image at a sample; and

29

30 Fig. 4 shows the variation in X-ray intensity as an  
31 electron beam is scanned across an aperture in front of  
32 a target.

33

34 With reference to Figs. 1 and 2, the X-ray generator 1  
35 comprises an evacuated and sealed X-ray tube 2,  
36 containing the following elements:

- 1           -     Electron gun 3
- 2           -     X-ray target 4
- 3           -     Internal electron mask 5
- 4           -     X-ray window 6 consisting of a thin tube of
- 5                     material with low X-ray absorption and high
- 6                     mechanical strength, for example beryllium.
- 7           This window also connects the tube 2 to the
- 8           target assembly 12 containing the target 4.
- 9

10       The tube 2 is contained within a housing 13. The  
11       generator 1 also includes a system 7 for focusing and  
12       steering the electron beam onto the target, a cooling  
13       system 8 to cool the target material, kinematic mounts  
14       9 to allow precise and repeatable mounting of X-ray  
15       devices for focusing the X-ray beam, and X-ray focusing  
16       devices 10 of varying configurations and methods. X-  
17       ray mirrors 10 are supplied in pre-aligned units so  
18       that re-alignment is not necessary after exchange.

19  
20       The X-ray tube 2 produces a well focused beam of  
21       electrons impinging on a target material 4. The  
22       electron beam may be focused into a spot or a line, and  
23       the dimensions of the spot and line as well as its  
24       position may be changed electronically. A spot focus  
25       having a diameter falling in the range 1 to 100  $\mu\text{m}$ ,  
26       generally 5  $\mu\text{m}$  or larger, may be achieved.  
27       Alternatively a line focus may be achieved whose width  
28       falls in a similar range, having a length to width  
29       ratio of up to 20:1.

30  
31       An electron beam mask of 5 of metal (eg tungsten) in  
32       the form of an internal electron beam aperture 11, with  
33       suitable dimensions, for example a rectangular slot for  
34       the line focus, may be used with suitable feedback and  
35       control mechanisms to automatically align the focal  
36       spot and to maintain its position on the target, for



1 example by scanning the electron beam over the aperture  
2 11 and measuring the emerging X-ray intensity.

3

4 The electron beam is produced by an electron gun 3,  
5 consisting of a Wehnelt electrode and cathode. The  
6 cathode may be either:

- 7 - a filament of tungsten or alloy, for example  
8 tungsten-rhenium, having either a hairpin or a  
9 staple shape; or
- 10 - an indirectly heated activated dispenser cathode,  
11 which may be flat or of other geometry, for  
12 example a rod with a domed end.

13 The dispenser cathode has the advantage of extended  
14 lifetime and increased mechanical strength. With a  
15 flat surface the dispenser cathode has the further  
16 advantage of requiring only an approximate degree of  
17 alignment in the Wehnelt electrode.

18

19 Primary focus is achieved by an anode at a suitable  
20 distance from the electron gun.

21

22 A thin tube of material with low X-ray absorption but  
23 high mechanical strength and stability, such as  
24 beryllium, is used to form the exit window 6 for the  
25 emerging X-rays. The tube must exhibit good vacuum  
26 seal characteristics. This tube also forms the  
27 mechanical connection between the X-ray tube 2 and the  
28 target assembly 12. Such an arrangement saves space  
29 and complexity in the formation of X-ray windows.

30

31 The electron beam from the gun is centred in the X-ray  
32 tube 2 by a centring coil 14 or set of quadrupole  
33 lenses. Alternatively it may be centred by multipole  
34 lenses. The electron beam is focused to a spot of  
35 varying diameter. Focusing down to a diameter of less  
36 than 5  $\mu\text{m}$  or better may be achieved by an axial lens 7

1 consisting of either quadrupole, multipole or solenoid  
2 type.

3

4 The spot focus may be changed to a line focus with a  
5 further set of quadrupole or multipole lenses. Lines  
6 with an aspect ratio of greater than 10:1 are possible.  
7 A line focus spreads the load on the target. When  
8 viewed at a suitable angle, the line appears as a spot.

9

10 Lenses are preferably magnetic, but may be  
11 electrostatic. All the lenses are electronically  
12 controlled, enabling automatic and continuous alignment  
13 and scanning of the focal spot. Change from spot to  
14 line is also automatic, as is the change of beam  
15 diameter.

16

17 The target 4 is a metal, for example Cu, but it can be  
18 another material depending on the wavelength of the  
19 characteristic radiation required, for example Ag, Mo,  
20 Al, Ti, Rh, Cr, Co, Fe, W or Au. The target 4 is  
21 either perpendicular to the impinging electron beam, or  
22 may be inclined to decrease the absorption of the  
23 emitted X-rays.

24

25 The target is cooled either by:

- 26 - a jet of cooling fluid (water, air or another  
27 fluid) directed onto the rear surface of the  
28 target area by cooling nozzle 15; or
- 29 - conducted or convected heat transfer from the rear  
30 of the target 4.

31

32 The cooling fluid is circulated through an inlet 16 and  
33 outlet 17.

34

35 An increase in cooling efficiency (and hence an  
36 increase in the permissible target loading) may be

1 achieved by the use of a thin metal film of target  
2 material deposited on a thicker substrate made from a  
3 material with a high thermal conductivity (eg diamond).  
4 The target could comprise a thin solid of a single  
5 material or it could be laminated with a different  
6 material of high thermal conductivity. These targets  
7 may be used with different cooling geometries, for  
8 example those employing high or low water pressure or  
9 forced or natural convection.

10  
11 Both foil transmission and reflection targets may be  
12 used as a target 4.

13  
14 Integrated mechanical shutters 18 are positioned  
15 between the window 6 and the X-ray focusing elements  
16 10, to block the emerging X-ray beam.

17  
18 The placement of the shutter 18 before the focusing  
19 elements 10 protects the surface of the mirror from  
20 extended radiation damage.

21  
22 A compact X-ray detector may be included to monitor and  
23 continuously optimise the position of the electron  
24 focal spot. This may be a small solid state detector  
25 or other X-ray detecting device.

26  
27 The system encompasses an X-ray focusing device 10  
28 located close to the source to provide a magnified  
29 image of the focal spot at controlled varying distances  
30 from the source. Options for the X-ray focusing  
31 systems are:

- 32 1 Micromirrors: use specular reflectivity from a  
33 gold or similar coating of highly controlled  
34 smoothness (around 10 Å rms), from a circularly  
35 symmetric profile.  
36 - Ellipsoidal profile: gives focused beam of X-

1 rays (currently 300  $\mu\text{m}$  diameter 600 mm from  
 2 focal spot). Measured insertion gain of >  
 3 150 (could be 250+). Reason for close  
 4 coupling is so that a large solid angle of  
 5 radiation may be collected, but also focusing  
 6 element forms a magnified image of the focal  
 7 spot at the sample (low beam divergence but  
 8 high insertion gain)  
 9 - Paraboloidal profile: gives a nearly parallel  
 10 beam (expected gains around 200+)

11  
 12 2 Kirkpatrick-Baez type:

- 13 - Bent plates arranged in combinations of
- 14 elliptical or parabolic or combination
- 15 - Allows simple change of mirror profiles to
- 16 suit different applications

17  
 18 3 Other possibilities:

- 19 - Zone plates
- 20 - Bragg Fresnel optics
- 21 - Multilayer optics

22  
 23 The distance  $x$  between the focusing mirror 10 and the  
 24 source on the target 4 is small, usually less than 20  
 25 mm, preferably about 11 mm, to ensure close coupling.

26  
 27 Example

28  
 29 A number of copper-target X-ray tubes with focusing  
 30 collimators were constructed to the same basic  
 31 specifications shown in the table below.

32  
 33 Table of Specifications

34  
 35 X-ray tube target                      Copper, cooled by water or  
 36    forced air

1	Source size	15 $\mu\text{m}$ x 150 $\mu\text{m}$ viewed at 6°
2		
3	Present tube current	0.2 mA at 30 kV
4		
5	X-ray focusing	Ellipsoidal mirror, gold
6		surface
7		
8	Source-to-mirror	11 mm
9	distance	
10		
11	Solid angle of	8.0 x 10 <sup>-4</sup> sterad
12	collection	
13		
14	Beam convergence	10 <sup>-3</sup> rad
15	at sample	
16		
17	The cathode is at negative high voltage and the	
18	electron gun consists of a filament just inside the	
19	aperture of a Wehnelt grid which is biased negatively	
20	with respect to the filament. The electrons are	
21	accelerated towards the anode which is at ground	
22	potential and pass through a hole in the latter and	
23	then through a long pipe (tube 2) towards the copper	
24	target 4. An electron cross-over is formed between the	
25	Wehnelt and anode apertures and this is imaged on the	
26	target by the iron-cored axial solenoid 7 which	
27	surrounds the vacuum pipe. The best electron focus is	
28	obtained when the beam passes very accurately along the	
29	axis of the solenoid. Two sets of beam deflection	
30	coils 14, which may be iron-cored, are employed in two	
31	planes separated by 30 mm, mounted between the anode of	
32	the electron gun 3 and the axial solenoid 7 to centre	
33	the beam. Between the solenoid 7 and the target 4 is	
34	an air-cored quadrupole magnet which acts as a	
35	stigmator 19 in that it turns the circular cross-	
36	section of the beam into an elongated one. This	

1 quadrupole 19 can be rotated about the tube axis so as  
2 to adjust the orientation of the line focus. The beam  
3 can be moved about on the target surface 4 by  
4 controlling the currents in the four coils of the  
5 quadrupole 19.

6  
7 For a tube power below 2 watts the foil target is  
8 adequately cooled by radiation alone, but at higher  
9 powers forced-air or water-cooling is necessary. The  
10 tube may be operated continuously at 6 watts but the  
11 maximum power compatible with low damage to the target  
12 surface 4 is still to be established.

13  
14 Computer simulations show that the loading limit of a  
15 water-cooled copper target and a focus of  $15\text{ }\mu\text{m} \times 300$   
16  $\mu\text{m}$  is about 20 watts. Experiments suggest that this  
17 figure can be somewhat improved upon by increasing the  
18 turbulence in the flow of the coolant. Another  
19 approach is to sandwich a layer of a material with a  
20 very high thermal conductivity between a very thin  
21 copper target layer and a cooled copper block. The  
22 sandwiched layer may be a Type II diamond layer, and  
23 may be sandwiched between a  $5\text{ }\mu\text{m}$  thick copper target  
24 layer and a water-cooled copper block. Diamond has a  
25 thermal conductivity which is up to four times that of  
26 copper and our calculations show that its use should  
27 allow the permissible power dissipation to be  
28 approximately doubled.

29  
30 The electron source of a micro-focus X-ray tube must  
31 have a high brightness to produce gun currents of the  
32 order of 1 mA.

33  
34 An indirectly heated cathode a Few hundred micrometers  
35 in diameter may be used. The beam cross-section  
36 remains circular until the beam reaches the stigmator

1 quadrupole while it can be drawn out into a line  
2 between 10  $\mu\text{m}$  and 30  $\mu\text{m}$  in width and with a length-to-  
3 width ratio up to 20:1. Such an electron source  
4 consumes a much lower filament power than the hair-pin  
5 tungsten filaments customary for low-power  
6 applications; since it operates at a lower temperature,  
7 it can have a life of several thousand hours.

8  
9 The tube is run in a saturated condition in which the  
10 current is virtually independent of the filament  
11 temperature but is determined by the bias voltage  
12 between filament and Wehnelt electrode. This bias  
13 voltage is the potential drop produced by the tube  
14 current flowing through a high resistor; this form of  
15 autobias produces a very stable tube current which is  
16 readily controlled by varying the bias resistance.

17  
18 The electron-optical performance of the tubes has been  
19 investigated by fitting some of them with 20  $\mu\text{m}$  thick  
20 transmission targets. This allowed pinhole photographs  
21 of the focus to be made. A quick way of assessing the  
22 focus was to view the magnified shadow cast by a 200-  
23 or 400-mesh grid. The electron beam could also be  
24 scanned across a rectangular aperture immediately in  
25 front to the target. The results are shown in Fig. 4,  
26 which shows how the X-ray intensity varies as the  
27 electron beam is scanned across the aperture in front  
28 of the target. It can be seen that the intensity  
29 reaches a peak of about 4000 cps over a range of  
30 distance between 60 and 220 micrometres.

31  
32 The insertion gain of ellipsoidal mirrors was measured.  
33 This gain was defined as the ratio of  $\text{CuK}\alpha$  X-ray flux  
34 into the 0.3 mm diameter image of the X-ray source  
35 formed at a distance of 600 mm from the source to the  
36 flux into the same area without the mirror. Under

1     these conditions the cross-fire at the sample position  
2     is about 1 milliradian. For the best mirrors the  
3     insertion gain was 110.

4  
5     The X-ray intensity obtained as above was also compared  
6     with that obtained at the focus of a standard double  
7     Franks mirror arrangement used with an Elliot GX-21  
8     rotating anode X-ray generator operated at 2kW. (This  
9     is a conventional combination of X-ray tube and  
10    collimator for protein crystallography). When the tube  
11    according to the invention was operated at below 1  
12    watt, the intensity was only 25 times less than that  
13    from the rotating-anode operated at a power 2000 times  
14    greater. Further improvements are possible, both in X-  
15    ray tube power and in mirror performance. It should be  
16    noted that the insertion gain calculated simply on the  
17    basis of solid angles of the cone of radiation  
18    collected from the source and on the highest values of  
19    X-ray reflectivity which have been measured is  
20    approximately five times greater than that achieved so  
21    far.

22  
23    These and other modifications and improvements can be  
24    incorporated without departing from the scope of the  
25    invention.



## 1 CLAIMS

2

3 1. X-ray generator comprising an electron gun, an X-  
4 ray tube, electron focusing means and a target  
5 adapted to have an X-ray source formed thereon,  
6 the electron focusing means being arranged such  
7 that the X-ray source on the target may be varied  
8 in size and/or shape and/or position.

9

10 2. X-ray generator according to Claim 1, wherein the  
11 X-ray source on said target may be varied from a  
12 small diameter spot to a line of small width.

13

14 3. X-ray generator according to Claim 1 or 2, further  
15 comprising an X-ray exit window comprising a tube  
16 of material with low X-ray absorption and of a  
17 small diameter to allow close coupling of X-ray  
18 focusing devices.

19

20 4. X-ray generator according to Claim 3, wherein the  
21 material of the exit window has a high mechanical  
22 strength and is preferably beryllium.

23

24 5. X-ray generator according to Claim 3 or 4, wherein  
25 the exit window connects the X-ray tube and the  
26 target.

27

28 6. X-ray generator according to any preceding Claim,  
29 wherein the electron focusing means comprises an  
30 x-y deflection system for centring the electron  
31 beam in the X-ray tube.

32

33 7. X-ray generator according to Claim 6, wherein the  
34 electron beam focusing means further comprises at  
35 least one electron lens, preferably an axially  
36 symmetric or round lens, and at least one

- 1           quadrupole or multipole lens for focusing the  
2           electron beam to a line focus.  
3
- 4       8.    X-ray generator according to any preceding Claim,  
5           wherein the target is a metal foil transmission  
6           target, the metal being selected from the group  
7           Cu, Ag, Mo, Rh, Al, Ti, Cr, Co, Fe, W, and Au.  
8
- 9       9.    X-ray generator according to any preceding Claim,  
10          wherein the surface of the target impinged upon by  
11          the electron beam is orientated such that the  
12          plane of the target surface is perpendicular or at  
13          an angle to the axis of the X-ray tube.  
14
- 15       10.   X-ray generator according to any preceding Claim,  
16          wherein the target comprises a thin metal layer  
17          deposited on a thicker substrate of a material  
18          with high thermal conductivity, preferably  
19          diamond.  
20
- 21       11.   X-ray generator according to any preceding Claim,  
22          wherein the generator further comprises a target  
23          cooling means.  
24
- 25       12.   X-ray generator according to any preceding Claim,  
26          further comprising an electron mask having an  
27          aperture adapted to align the focal spot of the  
28          electron beam.  
29
- 30       13.   X-ray generator comprising an electron gun, an X-  
31          ray tube, a target and an X-ray exit window  
32          comprising a tube of material with low X-ray  
33          absorption and of small diameter to allow close  
34          coupling of X-ray focusing devices.  
35
- 36       14.   X-ray generator according to any preceding Claim,

- 1 further comprising an X-ray focusing means coupled  
2 closely to said target.  
3
- 4 15. X-ray generator according to Claim 14, wherein the  
5 X-ray focusing means comprises an X-ray mirror  
6 whose longitudinal alignment axis is arranged at  
7 an angle to the axis of the X-ray tube.  
8
- 9 16. X-ray generator according to Claim 15, wherein the  
10 angle is between  $80^\circ$  and  $90^\circ$ , preferably about  
11  $84^\circ$ .  
12

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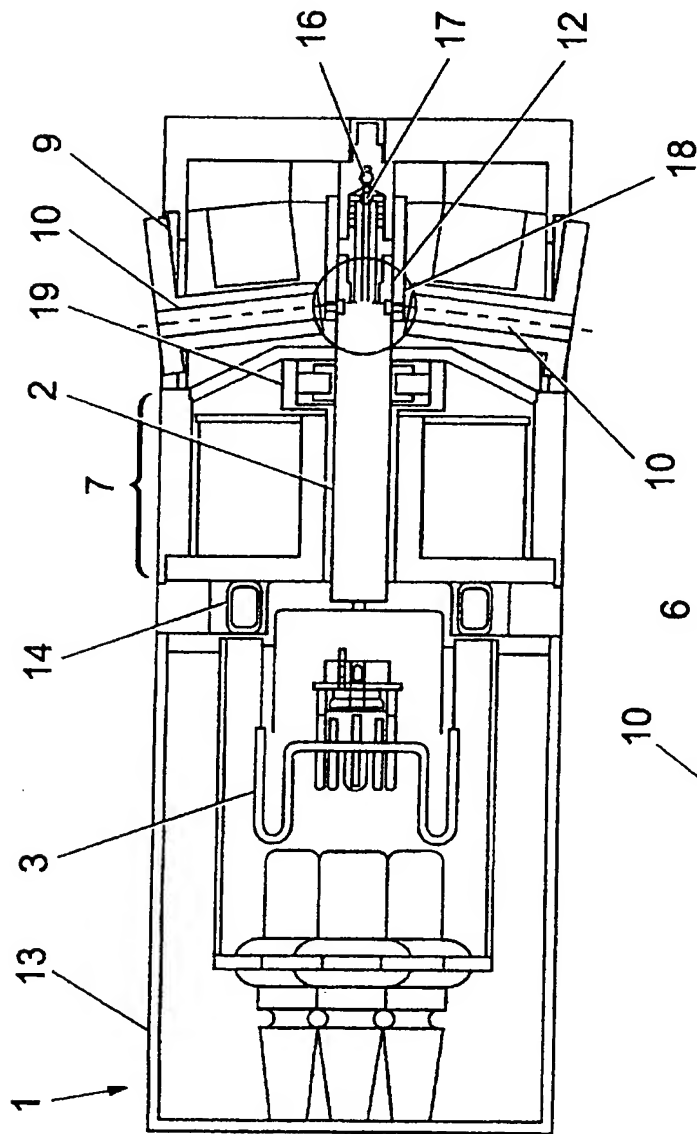


Fig. 1

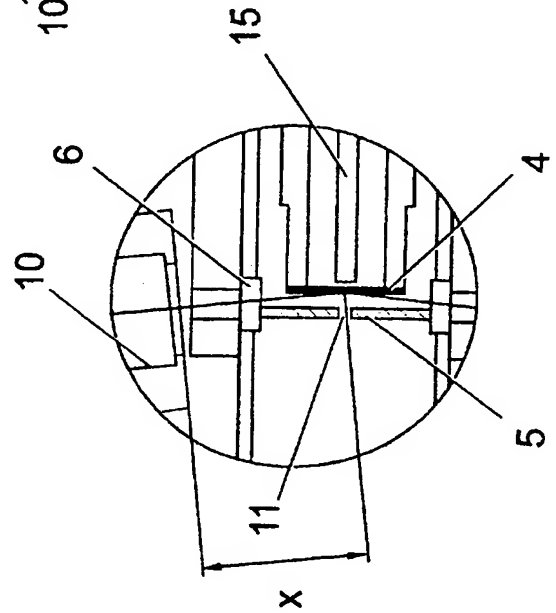
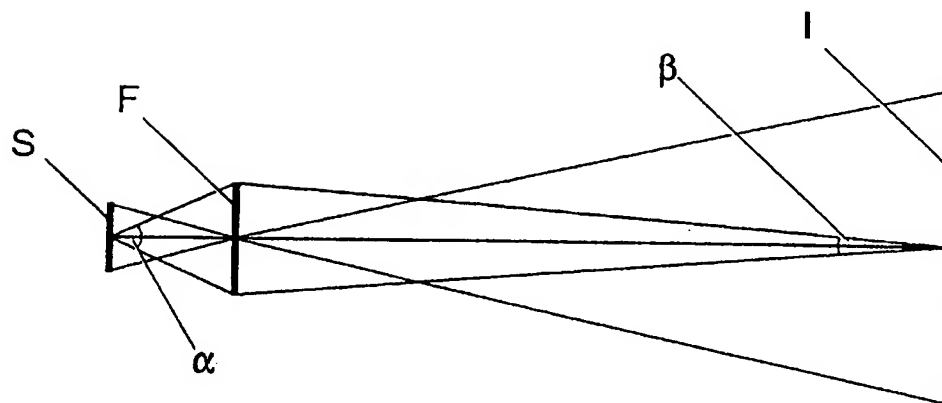
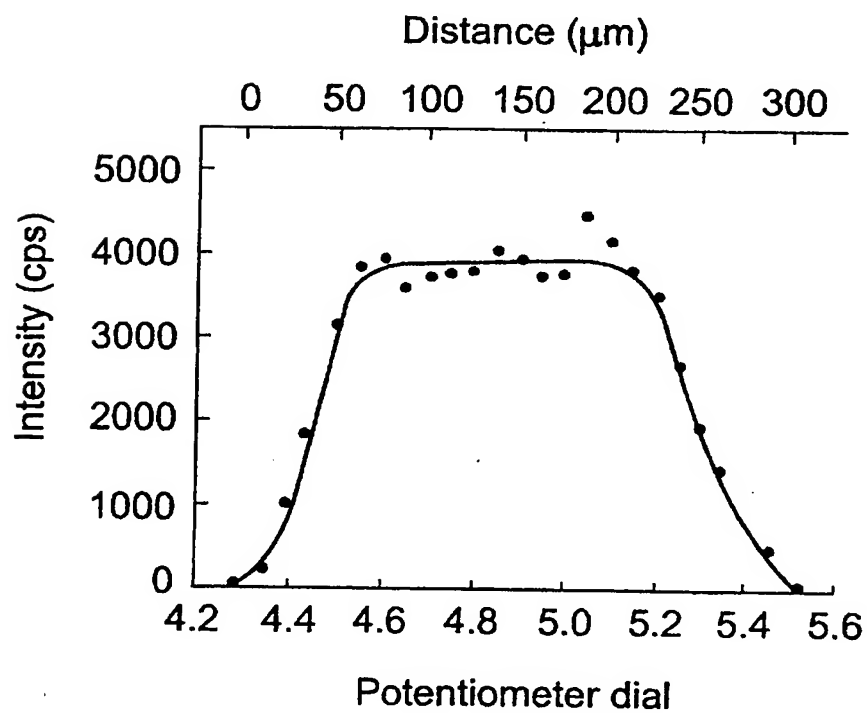


Fig. 2

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*Fig. 3**Fig. 4*

## INTERNATIONAL SEARCH REPORT

International Application No

PCT/GB 97/02580

A. CLASSIFICATION OF SUBJECT MATTER  
IPC 6 H01J35/14

According to International Patent Classification (IPC) or to both national classification and IPC

## B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)  
IPC 6 H01J

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Electronic data base consulted during the international search (name of data base and, where practical, search terms used)

## C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category	Citation of document with indication, where appropriate, of the relevant passages	Relevant to claim No.
X	US 3 732 426 A (SHIMIZU T) 8 May 1973 see figures see column 1, line 50 - column 2, line 43	1-5, 9, 13
Y	---	6-8, 10, 11, 14-16
Y	US 4 827 494 A (KOENIGSBERG WILLIAM D) 2 May 1989 see figure 1 see column 3, line 39 - line 55	6, 7
Y	EP 0 319 912 A (WANG CHIA GEE DR) 14 June 1989 see column 5, line 25 - line 38 see column 6, line 19 - line 33 ---	8, 10
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☒ Further documents are listed in the continuation of box C.☒ Patent family members are listed in annex.

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Date of the actual completion of the international search

5 January 1998

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# INTERNATIONAL SEARCH REPORT

Int. National Application No

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## C.(Continuation) DOCUMENTS CONSIDERED TO BE RELEVANT

Category	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
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